

Notice of References Cited

Application/Control No.

09/696,527

Applicant(s)/Patent Under
Reexamination
SU ET AL.

Examiner

Peter M Medley

Art Unit

2834

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Pelrine et al, "Electrostriction of Polymer Films for Microactuator", MEMS '97, Proceedings, IEEE., Tenth Annual International Workshop on , 1997 Page(s): 238 -243
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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